



Receipt
#9/CFR
9/2/99
285, Jones

786-149P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : JIN-YOUNG CHOI et al

Application No.: 09/139,270

Group: 3617

Filed : AUGUST 25, 1998

Examiner:

For: SEMICONDUCTOR WAFER PROCESSING SYSTEM

REQUEST FOR A CORRECTED OFFICIAL FILING RECEIPT

Honorable Commissioner of Patents
and Trademarks
Washington, D.C. 20231

DEC 23 1998
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Sir:

Attached hereto is the Official Filing Receipt in connection with the above-identified application.

THE FOLLOWING CORRECTION(S) IS /ARE RESPECTFULLY REQUESTED:

FOREIGN APPLICATION(S)--

Please Add:	--KOREA	97-46236	09/09/97
	KOREA	97-46237	09/09/97
	KOREA	97-46238	09/09/97
	KOREA	97-46239	09/09/97
	KOREA	97-46240	09/09/97
	KOREA	97-46241	09/09/97
	KOREA	97-46242	09/09/97
	KOREA	98-16904	05/12/98--

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It is respectfully requested that the United States Patent and Trademark Office forward a new Filing Receipt showing the correction(s) to the undersigned attorney as listed on the enclosed photocopy of our Declaration/Power of Attorney Document.

The correction(s) is /are due to an error by the United States Patent and Trademark Office, therefore no fee is due.



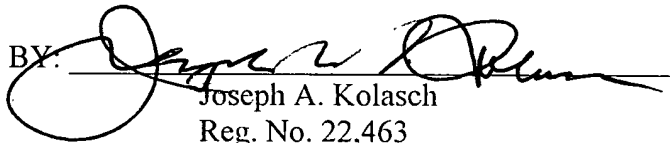
09/139,270

If necessary, the commissioner is hereby authorized in this, concurrent, and future replies, to charge payment of credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. 1.16 or under 37 C.F.R. 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

BY:


Joseph A. Kolasch
Reg. No. 22,463

P.O. Box 747
Falls Church, VA 22040-0747

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IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant(s): CHOI, Jin-Young; KANG, Hee-Young; PARK, Kyung-Dae;
KIM, Tae-su; LEE, Jun-Seong; KIM, Dong-Ho; KANG, Sung-Yun;
RYU, Jai-Moon; KANG, Han-Kil

Serial No.: New

Group:

Filed: August 25, 1998

Examiner:

For: SEMICONDUCTOR WAFER PROCESSING SYSTEM

LETTER

Honorable Commissioner of Patents
BOX PATENT APPLICATION
Washington, D.C. 20231

August 25, 1998
786-149P

Sir:

Under the provisions of 35 U.S.C. § 119 and 37 C.F.R. § 1.55(a), the applicant(s) hereby claim(s) the right of priority based on the following application(s):

<u>Country</u>	<u>Application No.</u>	<u>Filed</u>
Republic of Korea	97-46236	09/09/97
Republic of Korea	97-46237	09/09/97
Republic of Korea	97-46238	09/09/97
Republic of Korea	97-46239	09/09/97
Republic of Korea	97-46240	09/09/97
Republic of Korea	97-46241	09/09/97
Republic of Korea	97-46242	09/09/97
Republic of Korea	98-16904	05/12/98

A certified copy of the above-noted application(s) is(are) attached hereto.

If, necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. 1.16 or under 37 C.F.R. 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

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Attachment
/dlg

FILING RECEIPT



UNITED STATES DEPARTMENT OF COMMERCE
Patent and Trademark Office
ASSISTANT SECRETARY AND COMMISSIONER
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTORNEY DOCKET NO.	DRWGS	TOT CL	IND CL
09/139,270	08/25/98	3617	\$790.00	0786-0149P	14	16	2

BIRCH STEWART KOLASCH & BIRCH
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FALLS CHURCH VA 22040-0747



Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Application Processing Division's Customer Correction Branch within 10 days of receipt. Please provide a copy of the Filing Receipt with the changes noted thereon.

Applicant(s)

JIN-YOUNG CHOI; HEE-YOUNG KANG; KYUNG-DAE PARK; TAE-SU
KIM; JUN-SEOUNG LEE; DONG-HO KIM; SUNG-YUN KANG; JAI-MOON
RYU; HAN-KIL KANG.

FOREIGN FILING LICENSE GRANTED 09/10/98
TITLE
SEMICONDUCTOR WAFER PROCESSING SYSTEM

PRELIMINARY CLASS: 414

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15

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